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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OHTAKE, Fumio et al.

Group Art Unit: **2814**

Serial No.: **09/749,590**

Examiner: **MAI, Anh D.**

Filed: **December 28, 2000**

P.T.O. Confirmation No.: **4831**

For: **SEMICONDUCTOR DEVICE HAVING GATE ELECTRODES WITH POLYMETAL
STRUCTURE OF POLYCRYSTALLINE SILICON FILMS AND METAL FILMS (as
amended)**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: September 8, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office
Action dated May 7, 2003 for one month from August 7, 2003 to September 7, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large
entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit
Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Sadao Kinashi
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Atty. Docket No. **001752**

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